

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MAKOTO KUBOTA ET AL.) : Examiner: G. Mruk
Application No.: 10/561,247) : Group Art Unit: 2853
Filed: December 19, 2005) : Confirmation No.: 5989
)
For: PIEZOELECTRIC THIN FILM, METHOD :
OF MANUFACTURING PIEZOELECTRIC)
THIN FILM, PIEZOELECTRIC ELEMENT, :
AND INK JET RECORDING HEAD) December 19, 2007

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

Applicants hereby respond to the restriction requirement set forth in the Office Action dated November 21, 2007.

In the Office Action, the Examiner asserts that the subject application contains three patentably distinct groups and requires that one group be elected. In order to comply with the requirements of 37 CFR 1.143, Applicants elect Group I, Claims 1-6 and 15-17.

Favorable consideration is requested.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

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